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ATTY. DOCKET NO. APV31817

(National Phase of PCT/IB03/00895)

APPLICANT

Patrizia MELPIGNANO et al.

FILING DATE September 10, 2004 **GROUP**

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	5	6	0	2	6	7	9	02/97	Dolgoff et al.			
	5	9	0	0	9	8	2	05/99	Dolgoff et al.			

FOREIGN PATENT DOCUMENTS

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OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

	Madigan, C.F., et al. "Improvement of output coupling efficiency of organic light-emitting diodes by backside substrate modification", Paper No. XP-000950541, Applied Physics Letters, American Institute of Physics, New York, US, vol. 76, Number 13 (27 March 2000)
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EXAMINER DATE CONSIDERED 3/30/2006

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ATTY. DOCKET NO. APV31817

To be assigned

(National Phase of PCT/IB03/00895)

APPLICANT

Patrizia MELPIGNANO et al.

FILING DATE September 10, 2004 GROUP 2875

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